

# TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

## Title of Invention

LOW TEMPERATURE POLYSILICON THIN FILM TRANSISTOR AND  
METHOD OF FABRICATING LIGHTLY DOPED DRAIN THEREOF

Application Number :

Date :

First Named Applicant: Mr. Hsi-Ming Chang

Confirmation Number:

Attorney Docket Number: 13530-US-PA

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Submitted By:

Elec. Sign.

Sign. Capacity

Dr. Belinda Lee

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Agent

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Documents being submitted:	Files
us-assignment	13530-usassn.xml us-assignment.xsl us-assignment.dtd 13530assignment01.tif 13530assignment02.tif
us-request	13530-usrequ.xml us-request.dtd us-request.xsl
us-fee-sheet	13530-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
us-declaration	13530declaration01.tif
us-declaration	13530declaration02.tif
application-body	13530usf.xml application-body.dtd Image1.tif Image2.tif Image3.tif Image4.tif Image5.tif Image6.tif isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isogr1.ent isogr2.ent isogr3.ent isogr4.ent isolat1.ent isolat2.ent isomfrk.ent isomopf.ent isomscr.ent isonum.ent isopub.ent isotech.ent mathml2.dtd mathml2-qname-1.mod mmlalias.ent mmlextra.ent soextblx.dtd us-application-body.xsl

application-body-pdf-wrap	wipo.ent 13530usf-pdf-wrap.xml
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